



Patent
Attorney Docket No. 015290-506

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Ting CHIEN et al.

Group Art Unit: 1765

Application No.: 09/820,692

Examiner: K. C. Chen

Filing Date: March 30, 2001

Confirmation No.: 5245

Title: PLASMA ETCHING OF DIELECTRIC LAYER WITH SELECTIVITY TO STOP LAYER

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following extension of time is requested to: extend the time for responding to the Official Action dated October 7, 2003

a second month to March 8, 2004 ☐ \$155.00 ☒ \$310.00

A ☒ one ☐ two ☐ three ☐ four month Petition for Extension of Time was previously filed with the appropriate fee on February 6, 2004.

☐ An extension fee in the amount of \$ _____ is enclosed.

☐ The shortened statutory period has been reset by an Advisory Action dated _____.

☒ Charge \$ 310.00 _____ to Deposit Account No. 02-4800.

The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

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Date: March 8, 2004

By

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